IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Geun Su Lee et al.) I hereby certify that this paper and the documents referred to as enclosed
Serial No.: To be assigned	therewith are being deposited with the United States Postal Service as Express
Filed: November 26, 2003 (Herewith)	Mail, Airbill No. EV323777140USpostage prepaid, on November 26, 2003
For: Cleaning Solution for Photoresist and method for Forming Pattern Using the Same) in an envelope addressed to) Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450
Group Art Unit: To be assigned) Richard Zimmermann
Examiner: To be assigned))

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Submitted herewith for consideration by the examiner are copies of the documents identified on the attached Form PTO-1449. Entry and consideration of the submitted documents is solicited.

The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 13-2855.

Respectfully submitted,

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November 26, 2003

By:

Michael R. Hull Reg. No. 35,902

For m PTO-1449 (Modified)	U.S. Department of Commerce	Atty. Docket No.	Serial No.	
	Patent and Trademark Office	30205/39714	To be Assigned	
		Applicant		
INFORMATION DIS	CLOSURE STATEMENT	Geun Su Lee et al.		
		Filing Date	Group	
		November 26, 2003	To be Assigned	

U.S. PATENT DOCUMENTS						
*Examiner Initials	Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate
	5,374,502	12/20/1994	Tanaka et al.			
	5,474,877	12/12/1995	Suzuki			

FOREIGN PATENT DOCUMENTS								
*Examiner Initials	_	Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)					

EXAMINER	 D.	ATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.